ATTORNEY DOCKET 85168PCW UTILITY PATENT APPLICATION . Customer No. 01333 TRANSMITTAL UNDER 37 CFR 1.53(b) Express Mail Label No. Commissioner for Patents P.O. Box 1450 EV293511115US Alexandria, VA. 22313-1450 September 12, 2003 CHEMICAL MECHANICAL PLANARIZATION OF WAFERS USING FIXED POLISHING PADS AND A NANOPARTICLE COMPOSITION First Named Inventor (or Application Identifier): Venkata R. Gorantla, et al Enclosed are: Assignment of the invention to Specification X Certified copy of a priority Sheet(s) of drawing(s) 2. Associate Power of Attorney Information Disclosure Statement Under 37 CFR 8. 3. Combined Declaration for Patent Application and Power of Attorney: 4. Copy from a prior application (37 CFR 1.63(d) (for continuation/divisional with Box 11 completed) 4a. 4b. Deletion of Inventor(s). Incorporation by Reference (useable if Box 4b is Signed statement attached deleting inventor(s) named checked) The entire disclosure of the prior application, from in the prior application, see 37 CFR 1.63(d)(2) and which a copy of the oath or declaration is supplied under Box 4b, is considered as being part of the disclosure of the accompanying 1.33(b). application and is hereby incorporated by reference therein. X If a 111A application prior to examination of the above-identified application, amend the specification at Page 1, after the title, by inserting the following: -- CROSS REFERENCE TO RELATED APPLICATION Reference is made to and priority claimed from U.S. Provisional Application Serial No. 60/409,992, filed 09-12-2002, entitled PROCESS FOR CHEMICAL MECHANICAL POLISHING OF BLANKET FILM AND PATTERNED WAFERS USING FIXED ABRASIVE PADS. If a CONTINUING APPLICATION, check appropriate box and supply the requisite information: of prior application No: . Continuation-in-part (CIP) Divisional Continuation 12. X Please address all written communications to Thomas H. Close, Patent Legal Staff, Eastman Kodak Company, 343 State Street, Rochester, NY 14650-2201. Please Direct all telephone calls to Peyton C. Watkins at 585-477-8282. The filing fee has been calculated as shown below: FEE RATE NO. EXTRA NO. FILED FOR: \$ 750 \$ 234 BASIC FEE x 18 =13 - 20 = 33 TOTAL CLAIMS \$0 x 84 =- 3 = 0 INDEPENDENT CLAIMS \$0 + 280 MULTIPLE DEPENDENT CLAIM PRESENTED \$ 984 TOTAL \$ 984 Please charge my Eastman Kodak Company Deposit Account No. 05-0225 in the amount of A duplicate copy of this sheet is enclosed X The Commissioner is hereby authorized to charge any additional filing fees required under 37 CFR 1.16 or credit any overpayment to Eastman Kodak Company Deposit Account No. 05-0225. A duplicate copy of this sheet is enclosed. Attorney for Applicants Peyton C. Watkins/gms Registration No. 36,390 Telephone: 585-477-8282

Facsimile: 585-477-4646

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Venkata R. K. Gorantla, et al

CHEMICAL MECHANICAL
PLANARIZATION OF WAFERS OR
FILMS USING FIXED POLISHING
PADS AND A NANOPARTILCE
COMPOSITION

Serial No. To Be Assigned

Filed *Herewith*

Commissioner for Patents P.O. Box 1450 Alexandria, VA. 22313-1450

Sir:

Group Art Unit: To Be Assigned

Examiner: To Be Assigned

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Date: Licotinibu, 12, 2013

LETTER UNDER RULE 53

Pursuant to Rule 53, the above-identified application, enclosed herewith (including specification and claims), is being filed without a signed declaration or assignment in the names of the inventor(s), Venkata R. K. Gorantla, Suryadevara V. Babu. The declaration and assignment will be filed later.

Please address all correspondence to Patent Legal Staff, Eastman Kodak Company, Rochester, New York 14650-2201. Please direct all telephone communications to Peyton C. Watkins at 585-477-8282.

Respectfully submitted,

Attorney for Applicant() Registration No. 36,390

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